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CONFIRMATION NO. 2689

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SERIAL NUME 10/616,823		FILING DATE 07/10/2003 RULE	CLASS 438		GROUP ART UNIT 2827		ATTORNEY DOCKET NO. CU-3284 RJS		
APPLICANTS									
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** CONTINUING DATA **********************************									
** FOREIGN APPLICATIONS ************************************									
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/08/2003									
35 USC 119 (a-d) conditions				STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS TOT DRAWING CLAI 11 8 7		MS	INDEPENDENT CLAIMS 1	
ADDRESS 26530 LADAS & PARRY 224 SOUTH MICHIGAN AVENUE, SUITE 1200 CHICAGO, IL 60604									
TITLE Method for forming bit lines of semiconductor device									
FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following: RECEIVED All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue)									